

| Application/Control No. | Applicant(s)/Patent under Reexamination | |
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| 09/972,873 | TSUKAMOTO, SYUJI . | |
| Examiner | Art Unit | |
| Aristotelis M. Psitos | 2653 | |

| SEARCHED | | | | |
|----------|----------------|-----------|----------|--|
| Class | Subclass | Date | Examiner | |
| 369 | 59.11 7 | updated | | |
| | 275.2 | 5/31/2005 | AMP | |
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| INTERFERENCE SEARCHED | | | | |
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| Class | Subclass | Date | Examiner | |
| P6 Pubs 369 | 59.11 | | | |
| | 116 | 5,3105 | 8 | |
| | 275.2 | | | |
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| SEARCH NO (INCLUDING SEARCH | HES ISTRATEGY |) |
|--|------------------|------|
| | DATE | EXMR |
| East: 1) method near5 record\$5 2) reflectance 3) (irradi\$5 near5 (power laser) 4) reduc\$5 | | |
| 5) 3 same 4 6) 2 and 5 7) 1 and 6 | 5/31/2005 | |
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